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CONFIRMATION NO. 5813

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/593,857	09/22/2006 RULE	156	1792	58409/N305

APPLICANTS
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**** CONTINUING DATA *******
 This application is a 371 of PCT/KR05/00860 03/24/2005

**** FOREIGN APPLICATIONS *******
 REPUBLIC OF KOREA 10-2004-0020321 03/25/2004

**** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **** * SMALL ENTITY *
 06/18/2007

Foreign Priority claimed 35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWINGS 4	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 4
Verified and Acknowledged	/DUY NGUYEN DEO/ Examiner's Signature					

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TITLE
 Plasma Chamber Having Plasma Source Coil and Method for Etching the Wafer Using the Same

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